

Notice of References Cited	Application/Control No. 10/572,649	Applicant(s)/Patent Under Reexamination SCHULTE ET AL.	
	Examiner Dr. Kelechi C. Egwim	Art Unit 1796	Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-2006/0160974	07-2006	Schulte et al.	526/330
	B	US-			
	C	US-			
	D	US-			
	E	US-			
	F	US-			
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	H	US-			
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

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*	O	JP 05247121 A	09-1993	Japan	SHOBI et al.	-----
	P					
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NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
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